

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. ....09/810,387  
Confirmation No..... 8779  
Filing Date ..... March 15, 2001  
Inventor .....Craig M. Carpenter  
Assignee ..... Micron Technology, Inc.  
Group Art Unit..... 1763  
Examiner ..... R. Zervigon  
Attorney's Docket No. ....MI22-1559  
Customer No. ....021567  
Title:..... Chemical Vapor Deposition Apparatuses and Deposition Methods

**MPEP 1215.01 NOTICE TO BOARD OF PATENT APPEALS**

To:           Mail Stop Appeal Brief-Patents  
              Commissioner for Patents  
              P.O. Box 1450  
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Appellant herein notifies the Board that a Request for Continued Examination was filed in the instant application responsive to the Supplemental Examiner's Answer to address the new ground of rejection raised in the Answer and other new grounds of rejection raised in the Decision on Appeal.

Respectfully submitted,

Dated: October 15, 2008

By: /James E. Lake/  
James E. Lake  
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